

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Zhenjiang Cui, Jun Zhao, Rick J. Roberts, Shulin Wang, Errol A. C. Sanchez, and  
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Serial No.: Filed: Herewith

Grp. Art Unit: Examiner: Not Known

Title of Application: Electron Beam Treatment of  $\text{Si}_x\text{N}_y$  Films

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

S I R:

Information Disclosure Statement under 37 CFR 1.98

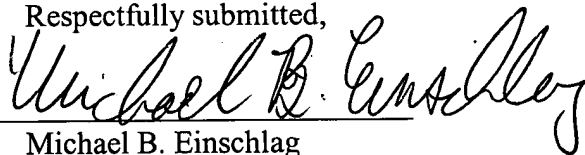
Applicant respectfully requests that the references listed on the attached form PTO-1449 be considered in the examination of the above-identified application. The following listing shall not be construed as a representation that no other art than that identified exists, or that each of the references is prior art.

Dated:

Feb. 12, 2004

By

Respectfully submitted,



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